



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Kenji NISHI

Group Art Unit: 2851

Application No.: 10/026,909

Examiner: H. Nguyen

Filed: December 27, 2001

Docket No.: 111586

For: MANUFACTURING METHOD IN MANUFACTURING LINE, MANUFACTURING METHOD FOR EXPOSURE APPARATUS, AND EXPOSURE APPARATUS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits after the filing of a Request for Continued Examination under 37 C.F.R. §1.114. No certification or fee is required.
- ☒ 2. The references were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.

Respectfully submitted,

Mario A. Costantino  
Registration No. 33,565

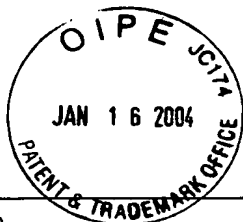
Klifton L. Kime  
Registration No. 42,733

MAC:KLK/kzb

Date: January 16, 2004

OLIFF & BERRIDGE, PLC  
P.O. Box 19928  
Alexandria, Virginia 22320  
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
--

Sheet 1 of 1Form PTO-1449  
(REV. 8-83)US Dept. of Commerce  
PATENT & TRADEMARK OFFICEATTY DOCKET NO.  
111586APPLICATION NO.  
10/026,909

## INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

APPLICANT(S)  
Kenji NISHIFILING DATE  
December 27, 2001GROUP  
2851

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
		5,826,129	10/1998	Hasebe et al.	396	611
		5,907,392	05/1999	Makinouchi	355	53
		6,027,262	02/2000	Akimoto	396	611
		6,262,796 B1	07/2001	Loopstra et al.	355	53
		6,327,022 B1	12/2001	Nishi	355	53

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
		EP 0 951 054 A1	10/10/1999	EP		

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)


EXAMINER

DATE CONSIDERED

Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Date: January 16, 2004